

IN THE UNITED STATES PAT	ENT A	AND TRADEMARK OFFICE
n re Application of:)	·
AKIRA UNNO, et al.	:	Examiner: Matthew W. Such
ARIKA UNIVO, CL al.		Group Art Unit: 2891
Application No.: 10/532,078		
Intl. Filing Date: October 8, 2004)	
371(c) Date: April 21, 2005	;)	
For: ORGANIC SEMICONDUCTOR DEVICE, PROCESS FOR PRODUCING THE SAME, AND ORGANIC SEMICONDUCTOR APPARATUS	; ; ; ;	January 9, 2007
Commissioner for Patents	,	

INFORMATION DISCLOSURE STATEMENT

Sir:

Alexandria, VA 22313-1450

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents, other than the U.S. patent documents, are enclosed. Also enclosed is an English-language abstract for each of the listed Japanese documents.

The following documents were cited in the International Search Report and/or Written Opinion which issued in the corresponding international application:

Japan 2004-165427; Europe 1 385 220; Japan 2004-55654; Europe 1 006 152;

Japan 2000-256527; U.S. Patent No. 6,252,002; the M. Yoshida article; U.S. Patent No.

5,500,537; and Japan 3-255669. A copy of the International Search Report and a copy of the Written Opinion are enclosed.

The following documents are discussed at the following pages of the specification:

<u>Documents</u>	Page(s)
A. R. Brown, et al., Synthetic Metals, Vol. 68, 1994	3
Japan 7-206599	3
YY. Lin, et al., IEEE Electron Device Letters, Vol. 18, No. 12, December 1997.	3
Japan 2001-94107	4
U.S. 6,433,359	4
M. Yoshida, et al., Synthetic Metals, Vol. 137, 2003	4
WO 03/041185	5

U.S. Patent Nos. 5,546,889, 5,556,706, and 5,912,473 are believed to be in the same patent family as Japan 7-206599; U.S. Publication No. 2004/0012018 and Europe 1 385 220 are believed to be in the same patent family as Japan 2004-55654; U.S. Patent No. 6,252,002 and Europe 1 006 152 are believed to be in the same patent family as Japan 2000-256527; and U.S. Patent No. 5,500,537 is believed to be in the same patent family as Japan 3-255669.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. § 1.97(c)(2) is believed due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be initialed and returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Costa Mesa,

California office at (714) 540-8700. All correspondence should continue to be directed to

our below-listed address.

Respectfully submitted,

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE OF ELIST OF REFERENCES CITED BY APPLICANT(S)		ATTY DOCKET NO. 03500.103410.				
		APPLICANT				
	(Use several sheets if necessary) JAN 1 0 2007		371(c) DATE: April 21, 2005		GROUP 2891	
	18	k É	U.S. PATENT DOCUMENTS			
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	7,008,701	03/07/06	Notsu, et al.	428	641	
	6,828,214	12/07/04	Notsu, et al.	438	455	
	6,783,588	08/31/04	Aoto, et al.	117	4	
	6,639,327	10/28/03	Momoi, et al.	257	913	<u> </u>
	6,613,678	09/02/03	Sakaguchi, et al.	438	695	
	6,593,211	07/15/03	Sato	438	455	
	6,569,748	05/27/03	Sakaguchi, et al.	438	455	
	6,506,665	01/14/03	Sato	438	458	
	FOREIGN PATENT DOCUMENTS					
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	1 385 220	01/28/04	Europe			
	1 006 152	06/07/00	Europe			
	2004-165427	06/10/04	Japan			Abstract
2	2004-55654	02/19/04	Japan			Abstract
	2001-94107	04/06/01	Japan			Abstract
	2000-256527	09/19/00	Japan			Abstract
	7-206599	08/08/95	Japan			Abstract
	3-255669	11/14/91	Japan			Abstract
	03/041185	05/15/03	PCT/WO			
) (Including Author, Title, Date, Pertinent	Pages, Etc.)		
			sal relation between conc emiconductors", Synthet			
YY. Lin, et al., "Stacked Pentacene Layer Organic Thin-Film Transistors with Improved Characteristics", IEEE Electron Device Letters, Vol. 18, No. 12, December 1997, pp. 606-608.						
		•	Potential Control of an Ins als, Vol. 137, 2003, pp. 96	-	or the High F	Performance
EXAMINER			DATE CONSIDERED			

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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	e several sheets if necessary)		371(c) DATE GROUP 2891		2891	
			U.S. PATENT DOCUMENTS			
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	6,433,359	08/13/02	Kelley, et al.	257	40	
	6,413,874	07/02/02	Sato	438	714	
	6,407,367	06/18/02	lto, et al.	219	390	
	6,375,738	04/23/02	Sato	117	89	
	6,335,269	01/01/02	Sato	438	509	
	6,252,002	06/26/01	Yamada, et al.	525	228	
	6,221,738	04/24/01	Sakaguchi, et al.	438	455	
	6,171,982	01/09/01	Sato	438	795	
	6,143,629	11/07/00	Sato	438	455	
	6,143,628	11/07/00	Sato, et al.	438	455	
	6,106,613	08/22/00	Sato, et al.	117	54	
	5,970,361	10/19/99	Kumomi, et al.	438	409	
	5,912,473	06/15/99	Wakita, et al.	257	40	
	5,556,706	09/17/96	Wakita, et al.	438	421	
	5,546,889	08/20/96	Wakita, et al.	117	84	
	5,500,537	03/19/96	Tsumura, et al.	257	40	
		FO	REIGN PATENT DOCUMENTS			
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
						
	0	THER DOCUMENT(S) (Including Author, Title, Date, Pertinen	t Pages, Etc.)		
	•		DATE CONSIDERED			

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April 21, 2005 2891 U.S. PATENT DOCUMENTS						
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	2006/0081880	04/20/06	Miyazaki, et al.	257	200	
	2005/0247928	11/10/05	Unno	257	40	
	2004/0012018	01/22/04	Tanabe	257	40	
	2004/0259315	12/23/04	Sakaguchi, et al.	438	285	
	2004/0231581	11/25/04	Aoto, et al.	117	2	
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